



**ELECTRONIC COPY**

LG760508288  
Report verification at igi.org



December 26, 2025

IGI Report Number **LG760508288**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **MARQUISE BRILLIANT**

Measurements **12.42 X 6.30 X 4.00 MM**

**GRADING RESULTS**

Carat Weight **1.76 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

December 26, 2025  
IGI Report Number **LG760508288**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MARQUISE BRILLIANT**  
Measurements **12.42 X 6.30 X 4.00 MM**

**GRADING RESULTS**

Carat Weight **1.76 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

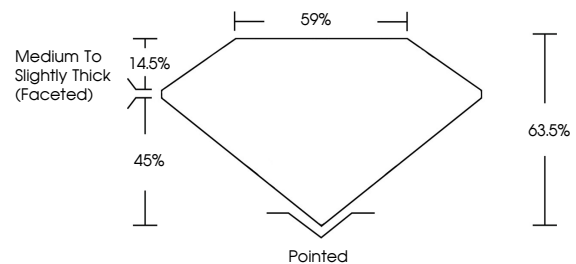
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG760508288**

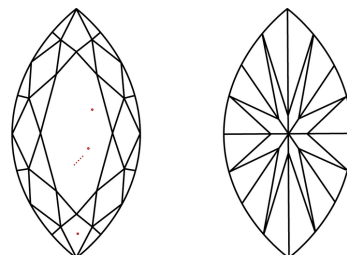
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

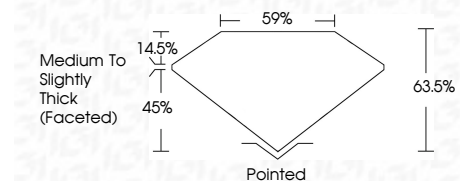
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG760508288**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



**IGI**



December 26, 2025  
IGI Report No **LG760508288**  
**MARQUISE BRILLIANT**

**12.42 X 6.30 X 4.00 MM**

Carat Weight **1.76 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**  
Table **63.5%**  
Girdle **59%**  
Medium to Slightly Thick (Faceted)

Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG760508288**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa